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## Nanotechnologies — Guidance on the measurement of nanoparticle number concentration

Nanotechnologies — Conseils pour la mesure de la concentration en nombre de nanoparticules

First edition

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### **ISO/PRF TS 24672**

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### **Foreword**

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The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO <u>documents</u> should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see <u>www.iso.org/directives</u>).

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This document was prepared by Technical Committee ISO/TC 229, Nanotechnologies.

Any feedback or questions on this document should be directed to the user's national standards body. A complete listing of these bodies can be found at <a href="https://www.iso.org/members.html">www.iso.org/members.html</a>.

### Introduction

Nanoparticle number concentration refers to the number of nanoparticles per unit of volume or mass in a sample. It is an important measurand when analysing dispersions containing nanoparticles. Nanoparticle number concentration is also considered a useful metric for supporting materials toxicological assessments. Furthermore, the capability to accurately measure nanoparticle number concentration can help industry to increase product manufacturing quality control and implement quality assurance. Currently, in most applications, nanoparticle number concentration is estimated from indirect mass-balance considerations and validated direct techniques for this measurand are required.

This <u>Technical Reportdocument</u> provides an overview of commonly used methods for the measurement of nanoparticle number concentration. These are the ensemble measurement techniques of differential centrifugal sedimentation (DCS) (line start incremental disc-type centrifugal liquid sedimentation), multi-angle dynamic light scattering (MDLS), small-angle X-ray scattering (SAXS) and ultraviolet-visible spectroscopy (UV-vis) and the particle counting techniques of particle tracking analysis (PTA), resistive pulse sensing (RPS), single particle inductively coupled plasma mass spectrometry (<u>sp-ICP-spICP-MS</u>), condensation particle counter (CPC), and differential mobility analysing system (DMAS).

The <u>Technical Reportdocument</u> focuses on the analysis of nanoparticles in suspensions (liquid dispersions) but also addresses aerosols measured using a CPC or a DMAS. Particles on surfaces or incapsulated in solid materials are not covered here. Nanoparticles rather than nano-objects are discussed as most techniques use the spherical approximation model to measure particle diameter which is more applicable to nanoparticles as opposed to <u>nanofibers\_nanofibres</u> and nanoplates. Most of the techniques discussed can also analyse particles of size greater than the nanoscale.

This <u>Technical Reportdocument</u> will provide guidance to help users to select the most appropriate techniques for nanoparticle number concentration measurements suitable for their applications.

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## Nanotechnologies — Guidance on the measurement of nanoparticle number concentration

### 1 Scope

This Technical Reportdocument provides an overview of methods used to determine the nanoparticle number concentration in liquid dispersions and aerosols. The methods described are the ensemble measurement techniques of differential centrifugal sedimentation (DCS), multi-angle dynamic light scattering (MDLS), small-angle X-ray scattering (SAXS) and ultraviolet-visible spectroscopy (UV-vis) and the particle counting methods of particle tracking analysis (PTA), resistive pulse sensing (RPS), single particle inductively coupled plasma mass spectrometry (sp-ICPspICP-MS), condensation particle counter (CPC), and differential mobility analysing system (DMAS). This document provides information on the use of each technique, along with considerations on sample preparation, advantages and limitations.

### 2 Normative references

There are no normative references in this document.

The following documents are referred to in the text in such a way that some or all of their content constitutes requirements of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

ISO TS 80004-1, Nanotechnologies – Vocabulary — Part 1: Core vocabulary

ISO/TS 80004-2, Nanotechnologies — Vocabulary — Part 2: Nano-objects

ISO TS 80004-6, Nanotechnologies — Vocabulary — Part 6: Nano-object characterization

ISO/TS 80004-8, Nanotechnologies — Vocabulary — Part 8: Nanomanufacturing processes

### 3 Terms and definitions

For the purposes of this document, the terms and definitions given in ISO TS 80004-1, ISO/TS 80004-2, ISO TS 80004-6, ISO/TS 80004-8 and the following apply.

ISO and IEC maintain terminological terminology databases for use in standardization at the following addresses:

- ISO Online browsing platform: available at <a href="https://www.iso.org/obp">https://www.iso.org/obp</a>
- IEC Electropedia: available at <a href="https://www.electropedia.org/">https://www.electropedia.org/</a>

### 3.1

### particle

minute piece of matter with defined physical boundaries

Note 1 to entry: A physical boundary can also be described as an interface.

Note 2 to entry: A particle can move as a unit.

### ISO/TS 24672:2023(E)

Note 3 to entry: This general particle definition applies to nano-objects.

[SOURCE: ISO/TS 80004-2:2015 26824:2022, 3.1]

### 3.2

### nanoparticle

nano-object with all external dimensions in the nanoscale where the lengths of the longest and the shortest axes of the nano-object do not differ significantly

Note 1 to entry: If the dimensions differ significantly (typically by more than 3three times), terms such as nanofibre or nanoplate may be preferred to the term nanoparticle.

[SOURCE: ISO/TS 80004-2:2015(en), 4.4]

### 3.3

### primary particle

original source particle (3.1) of agglomerates (3.4) or aggregates (3.5), or mixtures of the two

Note 1 to entry: Constituent particles of agglomerates or aggregates at a certain actual state may be primary particles, but often the constituents are aggregates.

Note 2 to entry: Agglomerates and aggregates are also termed secondary particles.

[SOURCE: ISO<del>/TS 80004-2:2015(en), 26824:2022,</del> 3.<del>2</del>1.4]

### 3.4

### agglomerate

collection of weakly or medium strongly bound *particles* (3.1) where the resulting external surface area is similar to the sum of the surface areas of the individual components

NOTE 1 to entry: The forces holding an agglomerate together are weak forces, for example, van der Waals forces, or simple physical entanglement.

NOTE 2 to entry: Agglomerates are also termed secondary particles and the original source particles are termed *primary particles*. (3.3).

[SOURCE: ISO/TS 80004-2:2015, 3.4]

### 3.5

### aggregate

particle (3.1) comprising strongly bonded or fused particles where the resulting external surface area is significantly smaller than the sum of surface areas of the individual components

Note 1 to entry: The forces holding an aggregate together are strong forces, for example, covalent or ionic bonds, or those resulting from sintering or complex physical entanglement, or otherwise combined former *primary particles*. (3.3).

Note 2 to entry: Aggregates are also termed secondary particles and the original source particles are termed primary particles.

[SOURCE: ISO/TS 80004-2:2015, 3.5]

### 3.6

### differential centrifugal sedimentation DCS

2

analytical centrifugation in which the sample is introduced at a defined position in a rotating disc partially filled with a fluid

Note 1 to entry: Normally the fluid has a density gradient to ensure uniform sedimentation.

Note 2 to entry: Normally there is one detector at a pre-determined position and the times taken for the *particles* (3.1) to reach this detector are recorded.

Note 3 to entry: Depending on the effective density of the particles, the technique can measure particle size and particle size distribution between 2 nm and 10  $\mu$ m, and can resolve particles differing in size by less than 2-\frac{\%}{\%}.

[SOURCE: ISO/TS 80004-6:2021, 4.4.5], modified — the term "line-start incremental disc-type centrifugal liquid sedimentation" has been removed.]

### 3.7

### condensation particle counter

instrument that measures the *particle* (3.1) number concentration of an aerosol using a condensation effect to increase the size of the aerosolized particles

Note 1 to entry: The sizes of particles detected are usually smaller than several hundred nanometres and larger than a few nanometres.

Note 2 to entry: A CPC is one possible detector suitable for use with a differential electrical mobility classifier (DEMC).

Note 3 to entry: In some cases, a condensation particle counter may be called a "condensation nucleus counter (CNC)".

[SOURCE: ISO/TS 80004-6:2021, 4.3.1] COURCE TO 2467

3.8

### differential mobility analysing system prf-ts-240

### DMAS

system to measure the size distribution of sub-micrometre aerosol *particles* (3.1) consisting of a differential electrical mobility classifier (DEMC), flow meters, a particle detector, interconnecting plumbing, a computer and suitable software

[SOURCE: ISO/TS 80004-6:2021, 4.3.3]

### 3.9

### dynamic light scattering

### DLS

method in which *particles* (3.1) in a liquid suspension are illuminated by a laser and the time dependant change in intensity of the scattered light due to Brownian motion is used to determine particle size

Note 1 to entry: Analysis of the time-dependent intensity of the scattered light can yield the translational diffusion coefficient and hence the particle size as the hydrodynamic diameter via the Stokes–Einstein relationship.

Note 2 to entry: The analysis is applicable to *nanoparticles* (3.2) as the size of particles detected is typically in the range 1 nm to 60006 000 nm. The upper limit is due to limited Brownian motion and sedimentation.

Note 3 to entry: DLS is typically used in dilute suspensions where the particles do not interact amongst themselves.

[SOURCE: ISO/TS 80004-6:2021, 4.2.7], modified — the term "photon correlation spectroscopy" has been removed.]

### 3.10

### nanoparticle tracking analysis

#### NTA

### particle tracking analysis

#### **PTA**

method in which *particles* (3.1) undergoing Brownian and/or gravitational motion in a suspension are illuminated by a laser and the change in position of individual particles is used to determine particle size

Note 1 to entry: Analysis of the time-dependent particle position yields the translational diffusion coefficient and hence the particle size as the hydrodynamic diameter using the Stokes-Einstein relationship.

Note 2 to entry: The analysis is applicable to *nanoparticles* (3.2) as the size of particles detected is typically in the range 10 nm to 2 000 nm. The lower limit requires particles with high refractive index and the upper limit is due to limited Brownian motion and sedimentation.

Note 3 to entry: NTA is often used to describe PTA. NTA is a subset of PTA since PTA covers larger range of particle sizes than nanoscale.

[SOURCE: ISO/TS 80004-6:2021, 4.2.8]

### 3.11

### resistive pulse sensing

### **RPS**

method for counting and size measurement of *particles* (3.1) in electrolytes by measuring a drop in electrical current or voltage as a particle passes through an aperture between two chambers

Note 1 to entry: The drop in current or voltage is proportional to the particle volume (Coulter principle).

Note 2 to entry: The particles are driven through the aperture by pressure or an electric field.

Note 3 to entry: The aperture can be nanoscale in size allowing the size measurement of individual nano-objects.

[SOURCE: ISO/TS 80004-6:2021, 4.4.7], modified — the terms "electrical sensing zone method" and "Coulter counter" have been removed.]

### 3.12

### single -particle inductively coupled plasma mass spectrometry sp-ICP\_spICP-MS

method using inductively coupled plasma mass spectrometry whereby a dilute suspension of nanoobjects is analysed and the ICP-MS signals collected at high time resolution, allowing particle-by-particle detection at specific mass peaks and number concentration, size and size distribution to be determined

[SOURCE: ISO/TS 80004-6:2021, 4.4.8]

### 3.13

### small-angle X-ray scattering

### **SAXS**

method in which the elastically scattered intensity of X-rays is measured for small-angle deflections

Note 1 to entry: The scattering is typically measured in the angular range up to  $5^{\circ}$ . This provides structural information about inhomogeneities in materials with characteristic lengths typically ranging from 1 nm to 100 nm. Under certain conditions the limit of 100 nm can be significantly extended.

[SOURCE: ISO-18115-1:2013, 3.18/TS 80004-6:2021, 4.24, modified, — Note 1 updated] 1 to entry has been replaced.]

### 3.14

### ultraviolet-visible spectroscopy

### **UV-Vis spectroscopy**

spectroscopy of radiation that consists of electromagnetic radiation with wavelengths in the ultraviolet and/or visible regions

[SOURCE: ISO/TS 80004-6:2021, 5.6]

### 4 Symbols and Abbreviated terms

For the purposes of this document, the following symbols and abbreviations apply.

BIPM\_CCQM bureau international des poids et mesures consultative committee for amount of

substance: metrology in chemistry and biology

CLS centrifugal liquid sedimentation
CPC condensation particle counter

DCS differential centrifugal sedimentation

DLS dynamic light scattering

DMA differential mobility analyser

DMAS differential mobility analysing system

ES electrospray

MDLS multi-angle dynamic light scattering

PTA particle tracking analysis

RPS resistive pulse sensing OPRF

SAXS small-angle X-ray scattering

sp-ICPspICP- single particle inductively coupled plasma mass spectrometry

MS

TRPS tunable resistive pulse sensing
UV-vis ultraviolet-visible spectroscopy

VAMAS Versailles project on advanced materials and standards

### 5 Overview

### **5.1 Introduction**

### 5.1 General

The number concentration of nanoparticles can be measured by techniques that average the number of particles measured over a specific sample volume (known herehenceforth referred to as "ensemble techniques") or count individual nanoparticles (known herehenceforth referred to as "particle counting," or "particle-by-particle techniques."). The ensemble techniques described in this document are DCS, MDLS, SAXS and UV-vis spectroscopy. In these ensemble techniques, the measured sample volume couldcan have some fractionation, for example in the case of DCS, but an ensemble of particles rather than individual particles are measured at the detector. The particle counting methods described are PTA, RPS, sp-ICPspICP-MS, CPC, and DMAS. All the techniques discussed in this document are used

for measuring nanoparticles in suspensions except for CPC and for DMAS, which are used to determine the particle number concentration in aerosols, which includes aerosolized suspensions.

The selection of the method of choice is ultimately dictated by the nature of the sample. The measurement of the number concentration of a particle population intrinsically depends on the limits of detection, sensitivity and resolution of the applied technique in terms of particle size. Depending on particle size, some techniques are capable of measuring the relative concentration of particle populations within the same sample. Some techniques measure aggregates or agglomerates as one particle, giving no information on primary particles unless separated by other means. Ensemble techniques generally require the knowledge of other particle characteristics such as size and refractive index in order to measure the number concentration.

A summary of VAMAS and BIPM-CCQM P194 international interlaboratory studies on the measurement of the number concentration of colloidal gold nanoparticles with selected techniques is described in Annex A and a guide on sample preparation for nanoparticles in suspension is described in Annex B.

### 5.2 Comparison of different techniques

The techniques described in this <u>Technical Reportdocument</u> are outlined in Table 1. This is not an exhaustive list of methods to measure nanoparticle number concentration measurements, others include electron microscopy and asymmetrical flow-field flow fractionation (AF4) coupled to PTA or ICP-MS, but are not discussed here.

The techniques in Table 1 and Clauses 6 and 7 are grouped by ensemble and particle counting, and then listed in alphabetical order. Methods for particles in suspensions (liquid dispersions) are listed first followed by those for aerosols (i.e. CPC and DMAS). Here, instrument footprint refers to the area that the instrument takes up in the laboratory.

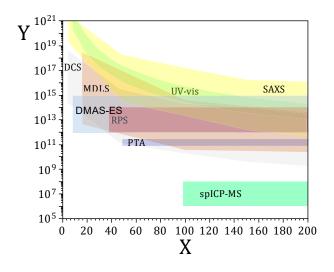
Table 1 — Comparison of techniques for measuring nanoparticle number concentration in suspensions (ensemble and particle counting) and airborne

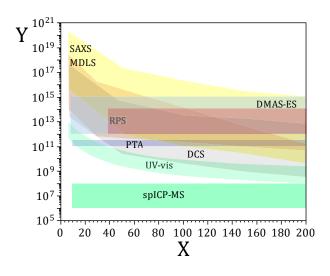
1	Techniques Technique	Veata Particle type rds/s	Critical input parameters	4 Advantages	Limitation <sub>Limitations</sub>
Ensemble	DCS	Organic and inorganic materials which absorb and/or scatter light or X- rays <del>.</del>	Effective density and complex refractive index of the particles, refractive index, average density and viscosity of the density gradient (medium), and some instrument- related parameters. The viscosity of the gradient, as well as the instrument- related parameters, can be replaced by a single method constant based on calibration	Multiple information (e.g. size and concentration). High resolution of the size distribution. Concentration per size population. Minimal sample preparation.	Longer sedimentation times for smaller nanoparticles or lower density materials. Calibration of particle losses required. Spherical model assumption applied. Spherical calibrant of known size and density required. Data post processing required.

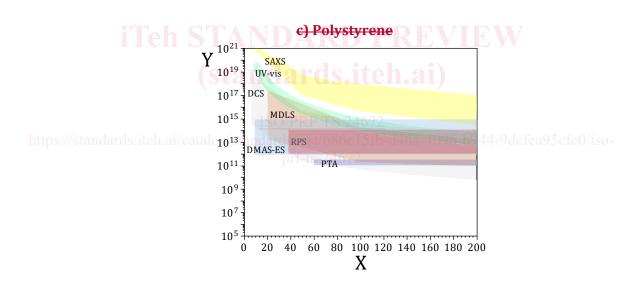
			with spherical reference particles of known effective density and size.		
	MDLS	Organic and inorganic materials which scatter light <del>.</del>	Complex refractive index and temperature of the medium and the particles, viscosity of the medium-	Multiple information (e.g. size and concentration). Rapid measurements.  a Concentration per size population. Minimal sample preparation.	Spherical model assumption applied. Lower performance for heterogeneous samples.
	saxs iTeh S7	Organic and inorganic materials which scatter X-rays:	Density of the materials (more specifically: effective electron density))	Multiple information (e.g. size, internal structure and concentration). Minimal sample preparation.	Spherical model assumption applied.
https://s	UV-vis tandards.iteh.ai/catalo	Organic and inorganic material which absorb and/or scatter light.	Average particle size and extinction cross-section-4672	Widely available. Rapid measurements.  a Minimal sample preparation.	Material dependent, particle extinction cross-section is not known for many materials and is also size dependent which limits its applicability.
Particle counting	PTA	Organic and inorganic materials, which scatter light <del>.</del>	Effective sensing volume of the instrument	Multiple information (e.g. size and concentration). Concentration per size population. High resolution of the size distribution. Rapid measurements.  a Low analyte volume.	Sample dilution to optimal concentration. Expert setting of signal thresholds. Calibration of sampling volume required. Dependencies on tracking algorithms.
	RPS	Organic and inorganic materials <del>.</del>	Size of the aperture selected <del>.</del>	Multiple information (e.g. size and concentration). High resolution of the size distribution. Concentration per size population. Rapid	Concentration calibrant can be required. Stable analyte dispersion in electrolyte solution required. Sample dilution to optimal concentration. Expert setting of signal thresholds.

				measurements.	
				a Low analyte volume.	
	<del>sp-ICP</del> spicp-MS	Particles with an element/ tag suitable for ICP-MS detection	The-Transport efficiency of particles-	Rapid measurement. a Multiple information [e.g. element mass per particle (from which size can be calculated by taking into account density and shape) and number concentration]. Low analyte volume. Very diluted	Expert selection of optimal particle concentration Expert setting of signal thresholds. Calculation of transport efficiency required. Limits of detection for sizing limited by procedural blanks, instrumental background and contribution of dissolved fraction.
	iTeł	sTANDA		matrix thus minimizing matrix effects. Minimal sample preparation. Information on the dissolved and nanoparticulate	$\mathbf{E}\mathbf{W}$
		(Stanua)	us.itei	fractions simultaneously.	
ł	ttps://standards.iteh.a	Airborne particles, and sincluding aerosolizedaerosolised particles from a suspension (liquid dispersion)	The-Flow rates of air or gas mixture (aerosol flow and sheath flow).	Rapid   measurement 59 (one second resolution). <sup>a</sup>	Sample dilution to optimal concentration. Calibration of transport efficiency required. For dispersions: artifactsartefacts derived from solutes in liquid dispersions (electrospray or nebulization_nebulisation).
Airborne particles	DMAS	Airborne particles, including aerosolizedaerosolised particles from a suspension (liquid dispersion)	The flow rates of air or gas mixture (aerosol flow and sheath flow). Voltage for DMA size discrimination. Efficiency and size distribution preservation of the aerosolization method.	Multiple information (e.g. size distribution and concentration) High resolution of the size distribution. Rapid measurement. a	Sample dilution to optimal concentration. Calibration of transport efficiency required. Less direct than CPC for aerosols. For dispersions: artifactsartefacts derived from solutes in liquid dispersions (electrospray or nebulization). nebulisation).
<sup>a</sup> Rapid measurements here means those that take approximately 60-seconds s or less per measurement.					









X Particle diameter (nm) Y Particle number concentration (kg-1)

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